

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor(s): Michel Puech

Appl. No.: 10/516,457

Confirm. No.: 2874

Filed: December 3, 2004

Title: HEATING JACKET FOR PLASMA  
ETCHING REACTOR, AND ETCHING  
METHOD USING SAME

PATENT APPLICATION

Art Unit: 1716

Examiner: Jeffrie R. Lund

**Customer No. 23910**

**REQUEST FOR CONTINUED EXAMINATION UNDER 37 C.F.R. § 1.114**

Mail Stop RCE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

This REQUEST FOR CONTINUED EXAMINATION (RCE) and REPLY is in response to the Final Office Action mailed March 18, 2010, and the Interview Summary mailed July 21, 2010. A Petition for Extension of Time is submitted herewith, together with the appropriate fee.

**Amendments to the Claims** begin on Page 2.

**Summary of the Interview** begins on Page 7.

**Remarks** begin on Page 8.